

SLOVENSKI STANDARD
oSIST prEN ISO 22765:2019
01-januar-2019

Tehnologija jedrskih goriv - Sintrani peleti (U,Pu)O₂ - Navodilo za pripravo keramografske preiskave mikrostrukture (ISO 22765:2016)

Nuclear fuel technology - Sintered (U,Pu)O₂ pellets - Guidance for ceramographic preparation for microstructure examination (ISO 22765:2016)

Kernbrennstofftechnologie - Gesinterte (U,Pu)O₂-Pellets - Leitfaden für die keramographische Herstellung der Proben zur Untersuchung des Feingefüges (ISO 22765:2016)

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Technologie du combustible nucléaire - Pastilles (U,Pu)O₂ frittées - Préconisations relatives à la préparation céramographique pour examen de la microstructure (ISO 22765:2016)

[SIST EN ISO 22765:2019](https://standards.iteh.ai/catalog/standards/iso/bs2ad835_e075_480f863_11e49edbf518/sist-en-iso-22765-2019)
Ta slovenski standard je istoveten z: **prEN ISO 22765**

ICS:

27.120.30	Cepljivi materiali in jedrska gorivna tehnologija	Fissile materials and nuclear fuel technology
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First edition
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Nuclear fuel technology — Sintered (U,Pu)O₂ pellets — Guidance for ceramographic preparation for microstructure examination

*Technologie du combustible nucléaire — Pastilles (U,Pu)O₂ frittées
— Préconisations relatives à la préparation céramographique pour
examen de la microstructure*

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ISO copyright office
Ch. de Blandonnet 8 • CP 401
CH-1214 Vernier, Geneva, Switzerland
Tel. +41 22 749 01 11
Fax +41 22 749 09 47
copyright@iso.org
www.iso.org

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The committee responsible for this document is ISO/TC 85, *Nuclear energy, nuclear technologies, and radiological protection*, Subcommittee SC 5, *Nuclear installations, processes and technologies*.

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